ΙN

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(FILE 'HOME' ENTERED AT 15:24:30 ON 18 APR 2008) FILE 'HCAPLUS, INSPEC, JAPIO, USPATFULL, USPATOLD, USPAT2' ENTERED AT 15:24:53 ON 18 APR 2008 L1604596 S (SINGLE OR MONO) (8A) (CRYSTAL?) L2 61094 S (GA OR GALLIUM) (8A) (NITRIDE#) L3 58411 S (NH3 OR AMMONIA) (8A) (SOLVENT# OR LIQUID#) L43904 S (MINERALIZER#) L52083 S (FEEDSTOCK#)(10A)(TRANSIT? OR CHANG? OR MORPH?) L6 2534 S L2 AND (POLYCRYSTAL?) L7 7554363 S (METAL?) => s 11 and 12 and 13 and 14 and 15 and 16 and 17 2 L1 AND L2 AND L3 AND L4 AND L5 AND L6 AND L7 => d 18 1-2 abs, bibANSWER 1 OF 2 USPATFULL on STN 1.8 AΒ A process for obtaining bulk mono-crystalline gallium-containing nitride, eliminating impurities from the obtained crystal and manufacturing substrates made of bulk mono-crystalline gallium-containing nitride has been now proposed. According to the invention, the process for obtaining of mono-crystalline gallium-containing nitride from the gallium -containing feedstock in a supercritical ammonia-containing solvent with mineralizer addition is characterized in that the feedstock is in the form of metallic gallium and the mineralizer is in the form of elements of Group I and/or their mixtures, and/or their compounds, especially those containing nitrogen and/or hydrogen, whereas the ammonia-containing solvent is in the form of the mineralizer and ammonia, there are two temperature zones in each step of the process, and the feedstock is placed in the dissolution zone, and at least one mono-crystalline seed is deposited in the crystallization zone, and following the transition of the solvent to the supercritical state, the process comprises the first step of transition of the feedstock from the metallic form to the polycrystalline gallium -containing nitride, and the second step of crystallization of the gallium-containing nitride through gradual dissolution of the feedstock and selective crystallization of gallium-containing nitride on at least one mono-crystalline seed at the temperature higher than that of the dissolution of the feedstock, while all the vital components of the reaction system (including the feedstock, seeds and mineralizer) invariably remain within the system throughout the whole process, and consequently bulk mono-crystalline gallium-containing nitride is obtained. The invention relates also the the post-treatment (slicing, annealing and washing) of the thus obtained crystals. The improved process and the bulk monocrystals obtained thereby are intended mainly for use in the field of opto-electronics. CAS INDEXING IS AVAILABLE FOR THIS PATENT. ΑN 2006:44069 USPATFULL ΤI Process for obtaining bulk mono-crystalline gallium-containing nitride

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PΙ
       US 2006037530
                           A1 20060223
                            A1 20031211 (10)
ΑI
       US 2003-537804
       WO 2003-JP15904
                                20031211
                                20050607 PCT 371 date
PRAI
       PL 2002-357697
                            20021211
       PL 2003-357698
                            20021211
       PL 2003-357699
                            20021211
       PL 2003-357700
                            20021211
       PL 2003-357701
                            20021211
       PL 2003-357702
                            20021211
       PL 2003-357703
                            20021211
       PL 2003-357705
                            20021211
DT
       Utility
FS
       APPLICATION
LREP
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       Number of Claims: 17
CLMN
ECL
       Exemplary Claim: 1
DRWN
       8 Drawing Page(s)
LN.CNT 1939
CAS INDEXING IS AVAILABLE FOR THIS PATENT.
L8
     ANSWER 2 OF 2 USPATFULL on STN
AΒ
       The invention relates to new improvements in a process for crystal
       growth in the environment of supercritical ammonia-containing solution,
       which are based on use of specific azide mineralizers and
       result in the improved bulk Group XIII element nitride
       monocrystals, in particular balk monocrystalline gallium
       -containing nitride, intended mainly for variety of
       nitride-based semiconductor products such as various
       opto-electronic devices. The invention further relates to a
       mineralizer used for supercritical ammonia-containing solution
       which comprises at least one compound selected from the group consisting
       of LiN.sub.3, NaN.sub.3, KN.sub.3, and CsN.sub.3.
CAS INDEXING IS AVAILABLE FOR THIS PATENT.
ΑN
       2006:37787 USPATFULL
TΙ
       Process for obtaining of bulk monocrystalline gallium
       -containing nitride
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PA
PΙ
       US 2006032428
                           A1 20060216
                                20030417 (10)
ΑI
       US 2003-519141
                            A1
       WO 2003-PL40
                                20030417
                                20041227 PCT 371 date
PRAI
       PL 2002-354740
                            20020626
       PL 2003-357697
                            20021211
DT
       Utility
FS
       APPLICATION
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22102, US CLMN Number of Claims: 30 ECL Exemplary Claim: 1 DRWN 8 Drawing Page(s)

LN.CNT 1293

CAS INDEXING IS AVAILABLE FOR THIS PATENT.